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CONTINUOUS-WAVE MICROCHIP LASER OPERATION OF Yb-DOPED GALLIUM GARNETS
J.M. Serres,¹ V. Jambunathan,² P. Loiko,^{1,3} X. Mateos,^{1,4} H. Yu,⁵ H. Zhang,⁵ J. Liu,⁶ A. Lucianetti,²
T. Mocek,² K. Yumashev,³ U. Griebner,⁴ V. Petrov,⁴ M. Aguiló,¹ F. Díaz¹

¹ Física i Cristal·lografia de Materials i Nanomaterials, Universitat Rovira i Virgili, Tarragona, Spain

² HiLASE Centre, Institute of Physics CAS, Dolní Břežany, Czech Republic

³ Center for Optical Materials and Technologies, Belarusian National Technical University, Minsk, Belarus

⁴ Max Born Institute for Nonlinear Optics and Short Pulse Spectroscopy, Berlin, Germany

⁵ State Key Laboratory of Crystal Materials, Shandong University, Jinan, China

⁶ College of Physics, Qingdao University, Qingdao, China

Ytterbium (Yb³⁺) ions are attractive for high-power, efficient and wavelength-tunable laser operation near 1 μm. Yb-lasers enable power scaling due to a low quantum defect (Stokes shift) between the pump λ_p and laser λ wavelengths and because they can be pumped with commercially available, high-power InGaAs laser diodes emitting at 930–980 nm. The Yb³⁺ ion is also free of unwanted parasitic processes such as excited-state absorption and up-conversion and it typically shows very high luminescence quantum yield leading to exceptionally high laser efficiency (> 80%). One of the hosts for Yb³⁺ doping are the cubic ordered and disordered garnets. They possess quite good thermo-optical and thermo-mechanical properties as well as relatively high thermal conductivity.

In the present report, we compare the microchip laser performance of a series of Yb-doped gallium garnets with ordered, Yb:Y₃Ga₅O₁₂ (Yb:YGG) and Yb:Lu₃Ga₅O₁₂ (Yb:LuGG) [1-3], as well as disordered, Yb:Ca₃(Nb_{1.5}Ga_{0.5})Ga₃O₁₂ (Yb:CNGG) and Ca₃Li_yNb_{1.5+y}Ga_{3.5-2y}O₁₂ (Yb:CLNGG) [4-6], crystal structure.

The Yb:LuGG and Yb:YGG crystals were grown in an oxygen atmosphere by the optical floating zone method, and Yb:CNGG and Yb:CLNGG ones were grown by the Czochralski method. From the as-grown bulks, rectangular samples were cut along the [111] crystallographic direction. Their thickness, aperture and doping level are specified in Table 1. The samples were wrapped with indium foil to improve the thermal contact and mounted in a water-cooled copper holder kept at ~12 °C.

Table 1. Compositional and Geometrical Parameters of the Studied Laser Crystals

Crystal	Dopin g, at.%	N _{Yb} , 10 ²⁰ cm ⁻³	Thickness, mm	Apertur e, mm ²
Yb:LuGG	7.13	9.4	6.00	3 × 3
Yb:YGG	7.35	9.7	6.02	3 × 3
Yb:CNGG	5.80	7.1	8.00	5 × 5
Yb:CLNGG	4.30	5.3	3.14	3 × 3

The microchip laser cavity consisted of a flat pump mirror (PM), AR coated for 0.9–1.0 μm and HR coated for 1.02–1.20 μm, and a set of flat output couplers (OC) with transmission T_{OC} = 1 %, 5 % or 10 % at the laser wavelength. The cavities contained no air gaps so that their lengths were equal to the geometrical length of the crystals. The fiber-coupled InGaAs diode was used, nominally emitting at around ~932. The pump beam was focused into the crystals with a lens assembly having a reimaging ratio of 1:1 and a focal length of 30 mm. The diode had a fiber core diameter of 105 μm and N.A. of 0.14. The diode provided a maximum output power of 25 W. The pump spot sizes in the focus w_p and confocal parameter 2z_R was then ~52 μm/1.0 mm. The crystals were pumped in a single-pass configuration.

The pump saturation intensity for the studied crystals was estimated to be ~20 kW/cm². For Yb:YGG, Yb:LuGG, and Yb:CNGG the pump absorption at high pump level was 60–70 % while for Yb:CLNGG it was ~50 % due to the shorter length of the crystal.

In Fig. 1, the absorption σ_{abs} and stimulated-emission cross-sections σ_{SE} spectra for the studied crystals are shown. The peak σ_{SE} values are slightly

higher for Yb:YGG and Yb:LuGG ($\sim 2.6 \times 10^{-20} \text{ cm}^2$) but Yb:CNGG and Yb:CLNGG provide broader emission bands (FWHM $\sim 24 \text{ nm}$).

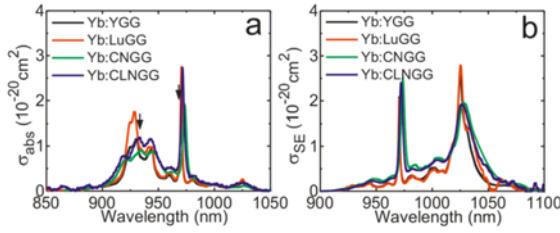


Fig. 1. Absorption (a) and stimulated-emission (b) cross-section spectra of the studied Yb-doped gallium garnets

Microchip laser operation was achieved with all garnets using the two described pump diodes. The input-output dependences for these lasers pumped at $\sim 932 \text{ nm}$ are shown in Fig. 2 with respect to the absorbed power. The Yb:LuGG crystal demonstrated superior laser performance. For $T_{OC} = 10\%$, a maximum output power of 8.97 W was achieved at 1040 nm with a slope efficiency $\eta = 75\%$. The optical-to-optical efficiency was 63% and the laser threshold was at $P_{abs} = 1.22 \text{ W}$. Using OCs with 5% and 1% transmission, the slope efficiency dropped to 69% and 62%, respectively.

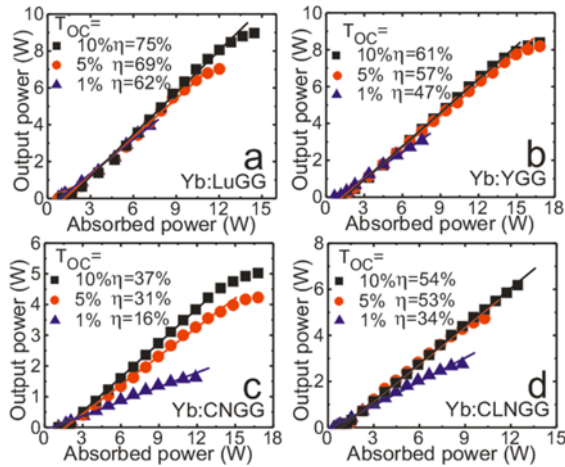


Fig. 2. Input-output dependences for microchip lasers based on Yb:LuGG (a), Yb:YGG (b), Yb:CNGG (c) and Yb:CLNGG (d) crystals. The pump wavelength is $\sim 932 \text{ nm}$, η – slope efficiency

The Yb:YGG crystal showed slightly inferior laser performance. The maximum output power was 8.40 W at 1042 nm with $\eta = 61\%$ for $T_{OC} = 10\%$. For Yb:CNGG and Yb:CLNGG microchip lasers, substantially lower output power was achieved. This decrease is attributed to the stronger thermo-optic effects in these crystals. The maximum output power generated with Yb:CLNGG was 6.1 W at 1039 nm with $\eta = 54\%$ and with Yb:CNGG it was 5.1 W at 1051 nm with $\eta = 37\%$ (both for $T_{OC} = 10\%$).

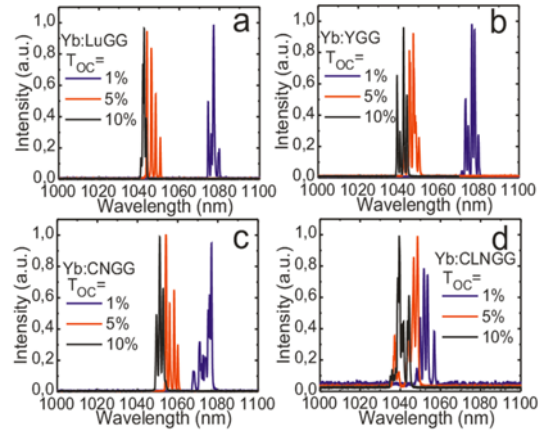


Fig. 3. Microchip laser emission spectra for Yb:LuGG (a), Yb:YGG (b), Yb:CNGG (c) and Yb:CLNGG (d) diode-pumped at 932 nm. The absorbed power is 7 W

For all crystals, thermal roll-over in the output dependences is observed. The range of P_{abs} corresponding to a linear input-output curve narrows at lower T_{OC} . For Yb:LuGG, Fig. 2(a), thermal roll-over starts at $P_{abs} \sim 7, 11$ and 13 W for $T_{OC} = 1\%$, 5% and 10% , respectively.

Typical laser emission spectra for all microchip lasers are shown in Fig. 3. All of them show a multi-peak behavior. For Yb:YGG and Yb:LuGG, the use of $T_{OC} = 1\%$ corresponded to laser oscillation at $\sim 1080 \text{ nm}$ and with 5% and 10% OCs, laser emission occurred at ~ 1050 and 1040 nm , respectively. For Yb:CNGG and Yb:CLNGG, the shift of the emission wavelength was less pronounced. In the latter case, λ_1 was $\sim 1052, 1048$ and 1039 nm for $T_{OC} = 10\%$, 5% and 1% , respectively.

The recorded laser emission spectra help to explain the peculiarities of the thermal rollover in the output dependences of the studied microchip lasers. The reason is a relatively high heat load under 932 nm pumping, as well as strongly localized heat deposition (as w_p was only $\sim 52 \mu\text{m}$). In particular, for Yb:LuGG laser, the value of ηh estimated as Stokes shift, was 13.2%, 10.9% and 10.2% for 1%, 5% and 10% OC, respectively. Thus, stronger heat load is expected for lower T_{OC} , leading to a thermal roll-over at lower P_{abs} , as seen in Fig. 3.

The observed blue-shift of the laser wavelength with the increase of T_{OC} is typical for quasi-three-level Yb lasers and is explained with the gain cross-section, σ_g , spectra, Fig. 4. Here, $\sigma_g = \beta \sigma_{SE} - (1 - \beta) \sigma_{abs}$ where β is the inversion ratio, $\beta = N_2/N_0$ where N_2 and N_0 are the number of ions excited in the upper laser level and overall number of ions, respectively. The gain spectra of Yb:LuGG, Yb:YGG and Yb:CNGG at very low β , typical for CW microchip lasers, are flat and very broad in the range from ~ 1060 to 1080 nm . For Yb:CLNGG, this range extends from 1040 to 1080 nm. With the increase of β , an absolute maximum is formed in the gain spectra and its position is shifting from 1045 to 1030 nm.

These spectral features are in good agreement with the recorded laser emission spectra, Fig. 3.

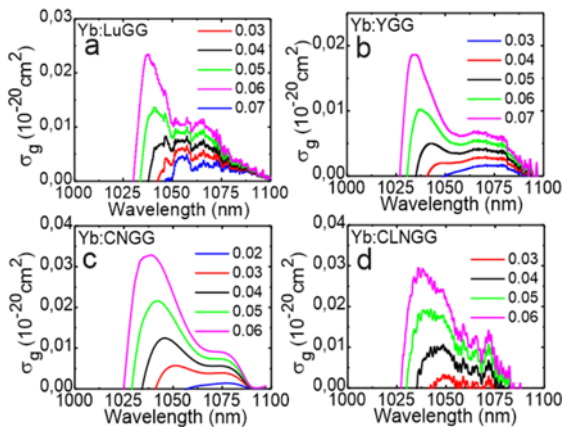


Fig. 4. Calculated gain cross-sections of Yb:LuGG (a), Yb:YGG (b), Yb:CNGG (c) and Yb:CLNGG (d) crystals for different inversion ratios β

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